

# Measurements and modeling of the thermal properties of a calorimeter having a sapphire absorber

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Y.H. Kim, H. Eguchi, C. Enss, Y.H. Huang,  
R.E. Lanou, H.J. Maris, A.N. Mocharnuk-Macchia,  
G.M. Seidel, B. Sethumadhavan and W. Yao



Brown University  
Department of Physics





## Objective

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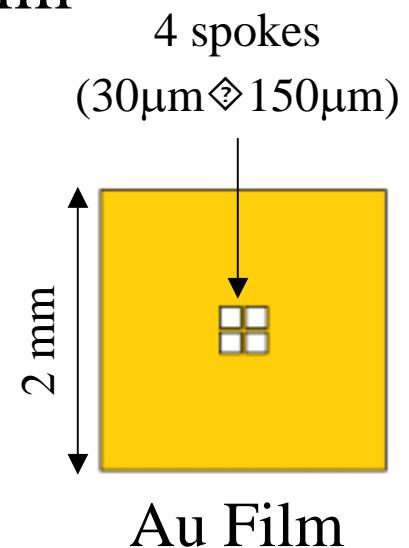
- Absorber: Sapphire
- Thermal connection: Au film
- Sensor: MMC (Au:Er)
  - Wide operating temperature
  - No additional heat dissipation
  - Fast to detect athermal signals
- Energy transfer
- Thermalization mechanism



## Different Experimental Conditions

- $^{241}\text{Am}$  Source (60 keV gamma rays)
  - Three different thickness of Au film

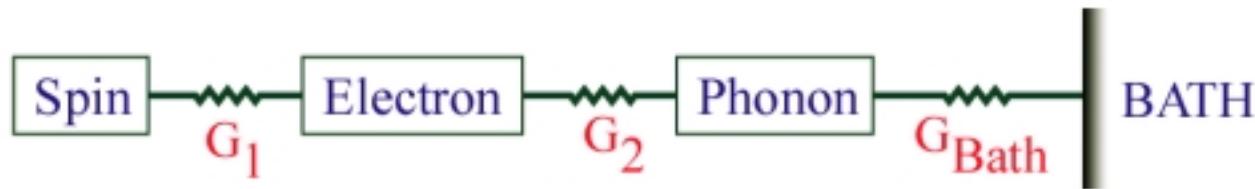
Experiment	Main film	Spokes
Case 1	80 nm	80 nm
Case 2	300 nm	300 nm
Case 3	80 nm	300 nm



- Experiment with a heater
  - Steady state heat input
  - Transient measurement



## Sub-thermal systems



- Spin: Erbium spins in *Au:Er*
- Electron: Electrons in Au film
- Phonon: Phonons in sapphire
- BATH: Thermal reservoir

Heat capacities are known

$G_1, G_2, G_{\text{Bath}}$  ?



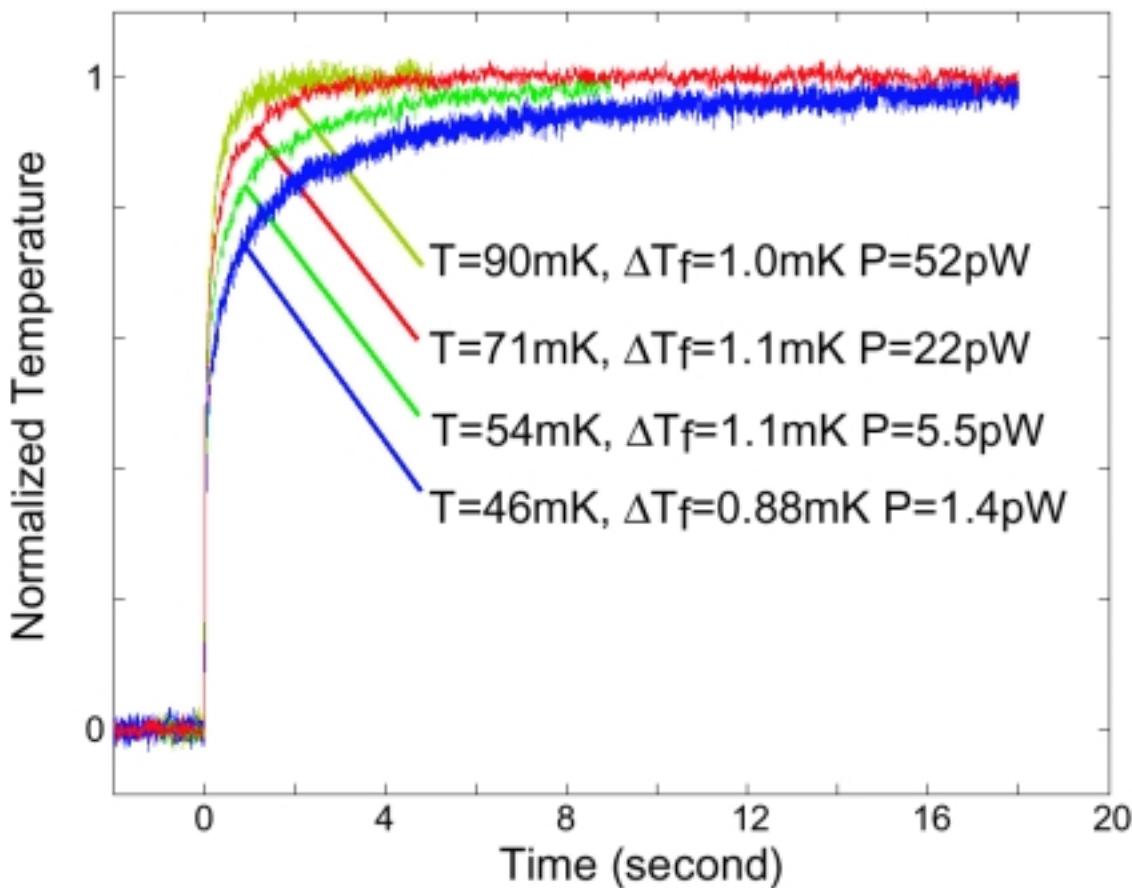
## Experiment with a heater

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- Heater: Au film ( $300\text{nm} \diamond 30\mu\text{m} \diamond 5.3\text{cm}$ )
- Steady state heat input:  
 $G_{\text{Bath}}$  is measured
- Transient measurement:  
Existence of Tunneling Systems  
weakly coupled to Lattice



## Transient measurement

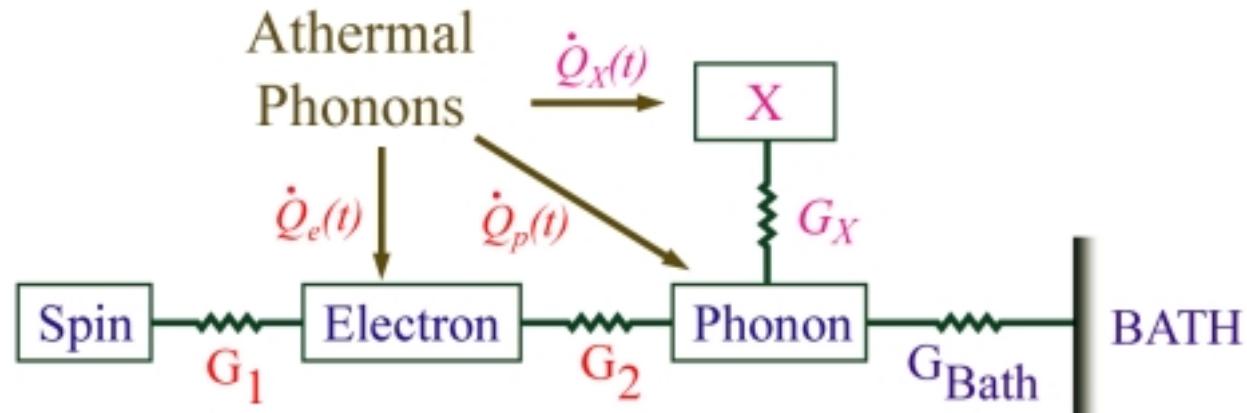


### Tunneling Systems

- Weakly coupled to lattice
- $C_{\text{lattice}} \ll C_x$
- Not single conductance



## Thermal model of particle detections



### 1. Athermal phonons with measurable life time

$$\dot{Q}_i(t) = \frac{E}{\tau_i} e^{-t/\tau}, \quad i = e, p, x \quad \tau = \left( \frac{1}{\tau_e} + \frac{1}{\tau_p} + \frac{1}{\tau_x} \right)^{-1}$$

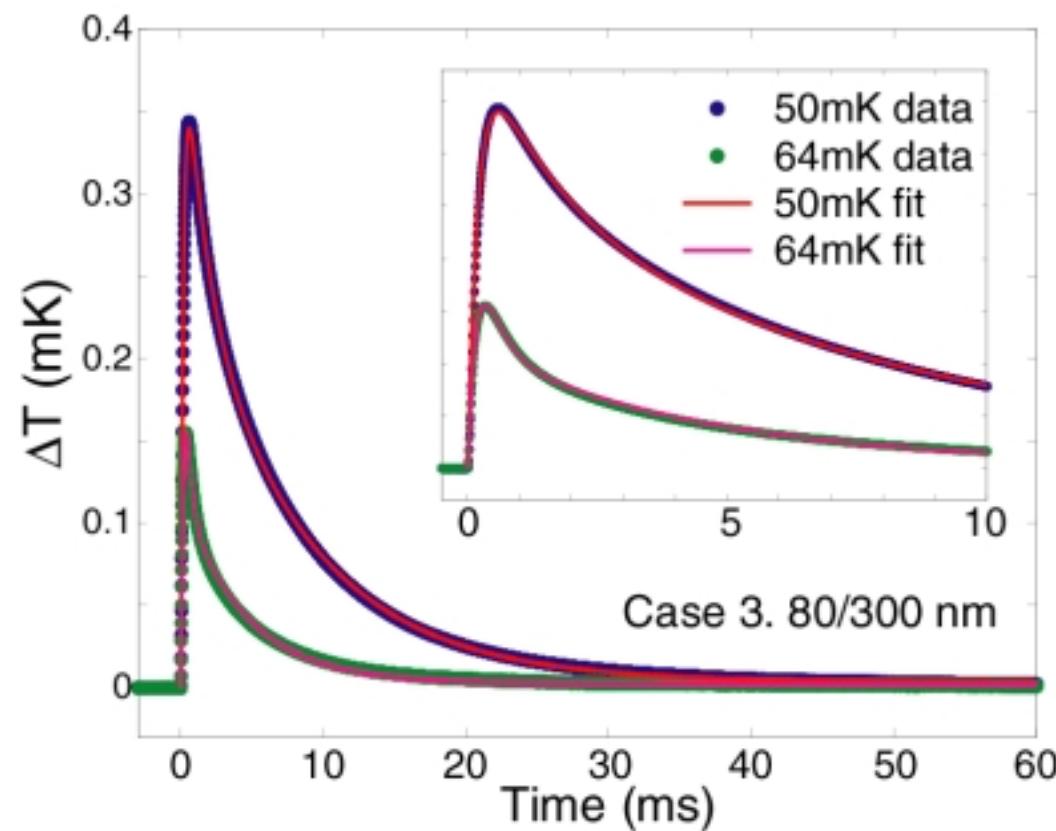
2. Thermal processes
3. Measure temperature of Spin.



## Parameters

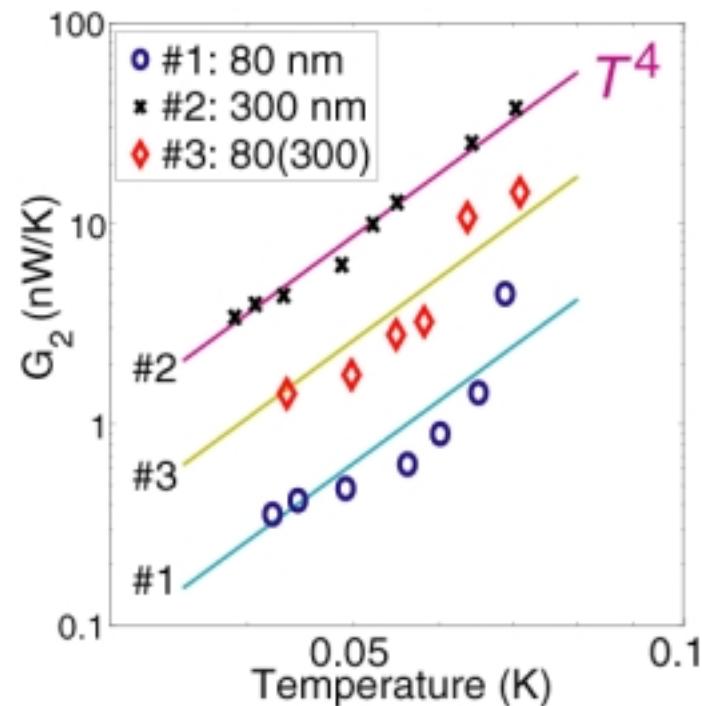
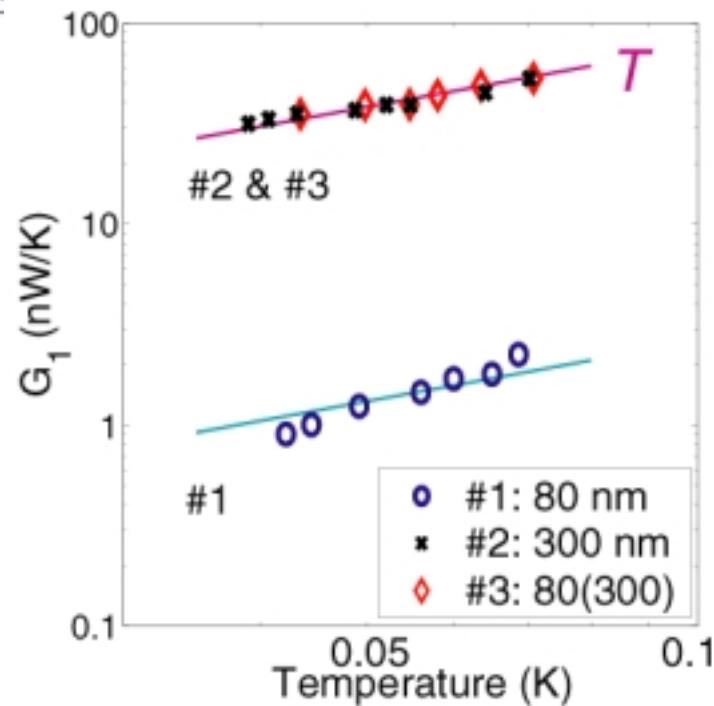
Major parameters:  $G_1$ ,  $G_2$ ,  $\tau_e$ , and  $\tau_p$

$C_x$ ,  $G_x$  fit after 10 ms,  $1/\tau_x$  small





## Thermal conductance, $G_1$ & $G_2$

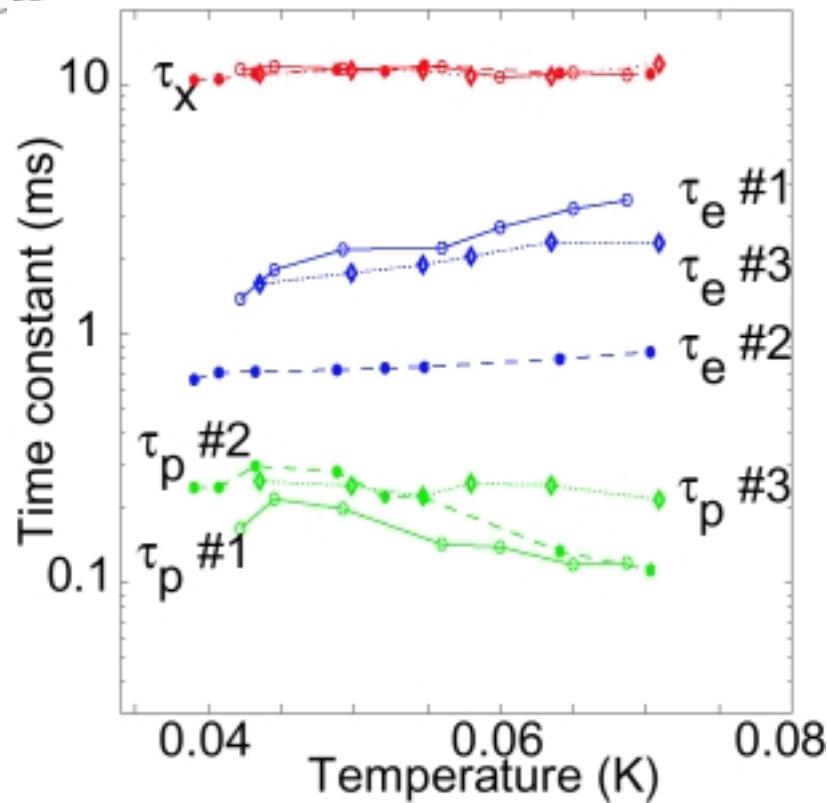


- $G_1 \sim T$
- Agreement within 15% of electronic thermal conductance of spokes

- $G_2 \sim T^4$ ,  $G_2 \sim V_{\text{film}}$
- $\Sigma = G_2 / 5V T^4$ , e-p in Au  
 $= 2.4 \times 10^8 \text{ W/m}^3 \text{K}^5$



## Time constants



$\tau_x$  (all cases)  $\sim 10$  ms

$\tau_e$  (case 1 & 3)  $\sim 2$  ms

(case 2)  $\sim 0.7$  ms

$\tau_p$  (all cases)  $\sim 0.2$  ms

$$1/\tau_x \square 1/\tau_l$$

$\tau_e$  has film thickness dependence



## Time constant $\tau_e$

$$\tau_e = \tau_{\text{geo}} / \eta$$

- Geometrical time constant:

$$\tau_{\text{geo}} \approx \frac{2V_{\text{crystal}}}{A_{\text{film}} \langle v_{\perp} \rangle} \approx 0.17 \text{ ms}$$

- Probability ( $\eta$ ) of athermal phonons to scatter electrons in Au.  $\lambda_{20K}$  in Au  $\sim 2 \mu\text{m}$

Experiment	Thickness	$\tau_e$	$\tau_{\text{geo}} / \tau_e$
Case #2.	<u>300 nm</u>	0.7 ms	0.24
Case #1.& #3.	<u>80 nm</u>	2 ms	0.085



## Time constant $\tau_p$

### Thermalization mechanism

- Inelastic impurity scattering
- Inelastic surface scattering

$$\tau_p \propto \frac{V_{\text{crystal}}}{A_{\text{crystal}}}$$

Measurement	Sapphire dimension	$\tau_l/(V/A)$
Present work	$2 \times 1 \times 0.5$ cm	1.5 ms/cm
CRESST	$4 \times 2 \times 1$ cm	1.3
CRESST	$4 \times 4 \times 4.1$ cm	1.9, 2.7

1000 scatters



## Summary

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- Electron-phonon interactions in Au film.

$$\Sigma = 2.4 \times 10^8 \text{ W/m}^3\text{K}^5$$

- Energy transfer from athermal phonons

$\tau_e$ : *Geometrical time constant and*

*Phonon attenuation in Au film.*

$\tau_p$ : *Inelastic surface scattering*

- Existence of TS

*Fast signals are not affected.*